PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:		NEW ASSIGNMENT	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:		ASSIGNMENT	ASSIGNMENT	
CONVEYING PARTY	/ DATA			
		Name	Execution Date	
Mao-Lin KAO			10/01/2012	
Hsu-Shui LIU			10/01/2012	
Tien-Chen HU			10/02/2012	
Li-Jen KO			10/01/2012	
Hsiang-Yin SHEN			10/01/2012	
Jiun-Rong PAI				
RECEIVING PARTY	DATA			
Name:	TAIWAN SEMICONDUCTOR MANUFACTURING COMPANY, LTD.			
Street Address:	No. 8, Li-Hsin Rd. VI			
Internal Address:	Hsinchu Science Park			
City:	Hsinchu			
State/Country:	TAIWAN			
Postal Code:	300-78			
PROPERTY NUMBE	RS Total: 1			
Property Type		Number		
Application Number: 13629		3629498	9498	
L				
CORRESPONDENC	E DATA			
Fax Number: <i>Correspondence will</i>	be sent via US M	lail when the fax attempt is unsucces	ssful.	
	94985106			
	01000100	Itillman@mwe.com, mweipdocket@mwe.com		
Phone: Email:	ltillman@r	. –		
Phone: Email: Correspondent Name	Itillman@r ə: John D. M	lagluyan		
Phone: Email: Correspondent Name Address Line 1:	ltillman@r ə: John D. M McDermo	lagluyan tt Will & Emery LLP		
Phone: Email: Correspondent Name Address Line 1: Address Line 2:	ltillman@r e: John D. M McDermo 4 Park Pla	lagluyan		
Phone: Email: Correspondent Name Address Line 1: Address Line 2: Address Line 4:	Itillman@r e: John D. M McDermo 4 Park Pla Irvine, CA	lagluyan tt Will & Emery LLP aza, Suite 1700	PATENT	

Total Attachments: 2 source=091393-0019_Assignment#page1.tif source=091393-0019_Assignment#page2.tif

ASSIGNMENT

In consideration of good and valuable consideration, the receipt of which is hereby acknowledged, the undersigned,

(1) Mao-Lin Kao, Hsu-Shui Liu, Tien-Chen Hu, Li-Jen Ko, Hsiang-Yin Shen, Jiun-Rong Pai

HEREBY SELL(S), ASSIGN(S) AND TRANSFER(S) TO

(2) <u>Taiwan Semiconductor Manufacturing Company</u> having a place of business at
(3) <u>No. 8, Li-Hsin Rd. VI, Hsinchu Science Park, Hsinchu, Taiwan 300-78, R. O. C.</u>
(hereinafter called "ASSIGNEE") the entire right, title and interest in and to any and all

improvements which are disclosed in the application for United States Letters Patent entitled

(4) <u>SEMICONDUCTOR PROCESSING STATION AND METHOD FOR PROCESSING</u> SEMICONDUCTOR WAFER

which application was:

(a) executed by the undersigned on (5a) The dates shown below

(b) filed on (5b)

And assigned Serial No.

including any and all United States letters Patents which may be granted on said application, and any and all extensions, divisions, reissues, substitutes, renewals or continuations of said application and patents, and the right to all benefits under all international conventions for the protection of industrial property and applications for said improvements.

It is hereby authorized and requested that the Commissioner of Patents issue any and all of said Letters Patent, when granted, to said Assignee, its assigns or its successors in interest or its designee.

Upon said consideration, it is further agreed that, when requested, without charge to but at the expense of said Assignee, the undersigned will execute all divisional, continuing, substitute, renewal, and reissue patent applications; execute all rightful other papers; and generally do everything possible which said Assignee shall consider desirable for aiding in securing and maintaining patent protection as provided herein.⁴

DATE:	INVENTOR(S)
2012/10/1	Mao-lin Kao Mao-Lin Kao
2012/10/01	Hau-Shui Liu Hsu-Shui Liu
2012/10/02	Ton Charlos Tien-Chen Hu
2012/10/1	Li-Jen Ko Li-Jen Ko
2012/10/1	Hstang - YEn Shon Hsiang-Yin Shen
20 (2/10/1	Jim Rong Pro Jiun-Rong Pai

PATENT REEL: 029339 FRAME: 0065

台積電編號: TSMC2012-0667; 本所編號: PECA 18628/5723

WITNESSES:

PATENT REEL: 029339 FRAME: 0066

RECORDED: 11/21/2012